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JUL 12 2005

Attorney's Docket No.: 42P16018

Patent

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kevin J. Lee

Application No.: 10/720,649

Filed: November 24, 2003

For: VERTICAL WAFER STACKING USING  
AN INTERPOSER

Examiner: Rao, Shrinivas H.

Art Unit: 2814

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8/18/05*Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450RESPONSE UNDER 37 C.F.R. §§ 1.116 AND 1.121

Sir:

In response to the Final Office Action mailed May 13, 2005, Applicant submits the following Amendment and Remarks. Claim Amendments begin on page 2 of this paper. Remarks begin on page 8 of this paper. Applicant respectfully requests that the Examiner reconsider the application.

It is not believed that extensions of time are required beyond those that may otherwise be provided for in documents accompanying this paper. However, if additional extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned under 37 C.F.R. §1.136(a). Any fees required therefore are hereby authorized to be charged to Deposit Account No. 02-2666. Please credit any overpayment to the same deposit account.

Kindly enter the following Amendments and consider the following Remarks.

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